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MAIL STOP PCT  
PATENT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Application No.: **10/594,480**

PCT Appl. No.: **PCT/JP2005/005768**

Applicant: Yoshiharu OHTA et al.

Filing Date: September 28, 2006

Group Art Unit: Unknown

Title: SEMICONDUCTOR POLISHING COMPOSITION

Docket No.: **2691-000052/US**

**REQUEST FOR RECORDATION OF  
INTERNATIONAL PRELIMINARY EXAMINATION REPORT**

**MAIL STOP PCT**

December 26, 2006

Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

Applicant attaches hereto an English translation of the International Preliminary Examination Report which has been issued in connection with the above-identified application. Please make this document part of the prosecution history of the present application.

Respectfully submitted,

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By:   
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Attachment: International Preliminary Examination Report